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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **MARUYAMA, Kenji, et al.**

Group Art Unit: **2891**

Serial No.: **10/532,249**

Examiner: **Steven J. Fulk**

Filed: **April 22, 2005**

P.T.O. Confirmation No.: 1069

For: **METHOD OF PRODUCING SEMICONDUCTOR DEVICE**

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: October 23, 2006

Sir:

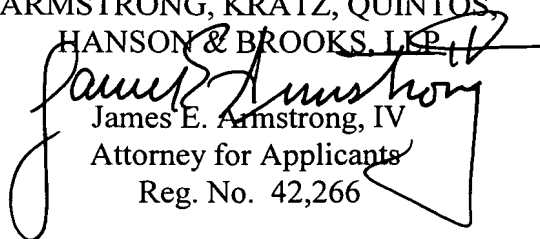
The undersigned attorney requests the status of the above-identified application.

The application was filed on **April 22, 2005**, in the U.S. Patent and Trademark Office and to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS
HANSON & BROOKS, LLP


James E. Armstrong, IV
Attorney for Applicants
Reg. No. 42,266

JAM/jkw
Atty. Docket No. **050256**
Suite 1000
1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



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